

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 8585

Takashi OHSAKO et al. : Docket No. 2003_1364A

Serial No. 10/677,221 : Group Art Unit 2823

Filed October 3, 2003 : Examiner Joannie Garcia

METHOD OF MANUFACTURING
SEMICONDUCTOR ELEMENT : Mail Stop: Amendment

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of March 9, 2005.

The fee of \$1,020.00 is

- (X) submitted herewith.
(to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
(Small entity status of this application is established by a Small Entity Status Assertion which
(is enclosed.
(has been previously submitted.

Respectfully submitted,

Takashi OHSAKO et al.

By _____

W. Douglas Hahm
Registration No.44,142
Attorney for Applicants

WDH/ck
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
September 9, 2005

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